

May 26 2005

SPW

THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Applicant:

Kramadhati V. Ravi et al.

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Art Unit: 2826

Serial No.: 10/809,243

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Examiner: Tuan N. Quach

Filed: March 25, 2004

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Atty Docket: ITL.1126US
P19032

For: Low Dielectric Constant
Carbon Films

§

Assignee: Intel Corporation

§

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REPLY TO PAPER NO. 0305

Sir:

In response to the office action mailed March 24, 2005, please amend the above-referenced patent application as follows:

Date of Deposit: May 24, 2005

I hereby certify under 37 CFR 1.8(a) that this correspondence is being deposited with the United States Postal Service as **first class mail** with sufficient postage on the date indicated above and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Cynthia L. Hayden
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